



報價單

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報價單號: RQ18080601
 報價日期: 2018/08/06
 對方單號:
 有效日期: 2018/09/05
 稅 別: 零稅 USD
 業務員: C06(Eric)

序號	產品編號	品 名 規 格	數量/單位	單 價	小 計
1	CNT0000026	S-200 原子層沉積系統 Savannah 200 ALD Includes: - S200 Base system with two precursor ports and two 50mL precursor cylinders - Three molded, closed loop, precursor heating jackets (not necessary for water) - ExposureMode - 200mm reaction chamber - Integrated, heated vapor trap - Field retrofit capability for full range of options - 14.6 CFM rotary vane pump (can be substituted for 20, 50, or 58.9 CFM dry pump) - User computer with Windows 7 OS Includes services: - Access to Veeco-CNT recipe database - Precursor advice - Science Team Support - Software maintenance releases Excludes: - Precursor chemicals (Customer consumable supply) - Fomblin oil, 2kg required, customer supplied **Options: 1. Additional Precursor Line(s) - up to 4 additional - Maximum of 6 precursor ports on system - Includes additional heater jackets and 50mL cylinders 2. High Concentration Ozone Generator, ~200ng/mL 3. Low Vapor Pressure Deposition (LVPD) Option - No Cylinder - For low vapor pressure precursors > 0.01 Torr 4. Solid Precursor Cylinder (150ml) for LVPD	1台	308,000	308,000
合計:			1台	USD	308,000

供應商: Veeco Instruments, Inc.
 代理商: 金巨達國際股份有限公司
 經辦: Ann Ouyang 歐陽儀 #23
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